



Image Rce/1763
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

March 8, 2004

In re the Application of

Kazuo ICHIKAWA et al.

Group Art Unit: 1763

Application No.: 09/670,877

Examiner: R. Zervigon

Filed: September 27, 2000

Docket No.: 107469

For: CVD SUBSTRATE AND CLEANING METHOD

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. §1.136(a)
AND TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith is a Request for Continued Examination for the above-identified patent application. The shortened statutory period for response having expired on January 7, 2003, an extension of time for a period of two months is hereby requested. Attached hereto is our Check No. 151845 in the amount of \$ 310.00 pursuant to 37 CFR §1.17. (Payment of \$110.00 for a one month extension was already made.)

The Commissioner is hereby authorized to charge any additional fee (or credit any overpayment) associated with this communication to Deposit Account No. 15-0461. Two copies of this petition are enclosed.

Respectfully submitted,

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JAO:SSK/ccs

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DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461
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